


<b>Search Notes</b> 	<b>Application/Control No.</b>  10626040	<b>Applicant(s)/Patent Under Reexamination</b>  LEBNER, MICHAEL
	<b>Examiner</b>  Lewis, Kim M	<b>Art Unit</b>  3772

<b>SEARCHED</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
602	41-43,52,54,57-59	5/23/07	kml
606	213-216	1	~

<b>SEARCH NOTES</b>		
<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>

<b>INTERFERENCE SEARCH</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>